



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3771**
Yoichiro NUMASAWA et al. : Docket No. 2003_1106A
Serial No. 10/642,619 : Group Art Unit 1754
Filed August 19, 2003 : Examiner Ngoc Yen M. Nguyen
APPARATUS AND METHOD FOR :
MANUFACTURING HALOGEN GAS AND :
HALOGEN GAS RECOVERY AND :
CIRCULATORY SYSTEM :

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of
March 24, 2005.

The fee of \$450.00 is

☒ (X) submitted herewith.

☐ () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

☐ () Small entity status of this application is established by a Small Entity Status Assertion
which

☐ () is enclosed.

☐ () has been previously submitted.

Respectfully submitted,

Yoichiro NUMASAWA et al.

By

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June 23, 2005